

<b>Information Disclosure Citation in an Application</b>	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

**U.S. PATENT DOCUMENTS**

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
	2,278,838	04/07/42	Groote et al.			03/11/40
	2,670,329	02/23/54	Jones			08/03/50
	2,689,244	09/14/54	Jones			06/23/50
	2,819,278	01/07/58	De Groot et al.			05/09/56
	2,877,179	03/10/59	Hughes et al.			03/26/56
	3,008,898	11/14/61	Hughes et al.			06/26/59
	3,052,298	09/04/62	Mallot			03/22/60
	3,065,247	11/10/62	De Groot et al.			11/23/55
	3,326,890	06/20/67	Engelskirchen et al			12/18/64
	3,336,980	08/22/67	Rike			02/09/67
	3,489,222	01/13/70	Millhone et al.			12/26/68
	3,601,194	08/24/71	Gallus			07/14/69
	3,647,507	03/07/72	Ashcraft			01/07/70
	3,689,418	09/05/72	Cenci et al.			12/14/70
	3,708,013	01/02/73	Dismukes			05/03/71
	3,709,298	01/09/73	Pramann			05/20/71
	3,902,557	09/02/75	Shaughnessy, et al.			03/25/74
	3,943,060	03/09/76	Martin, et al.			07/26/74
	3,983,941	10/05/76	Fitch			11/10/75
	4,052,345	10/04/77	Austin, et al.			06/25/75
	4,228,277	10/14/80	Landoll			02/12/79
	4,441,556	04/10/84	Powers, et al.			08/17/81
	4,499,214	02/12/85	Sortwell			05/03/83
	4,619,776	10/28/86	Mondshine			08/09/85
	4,662,448	05/05/87	Ashford, et al.			04/25/86
	4,702,319	10/27/87	Bock, et al.			12/29/86
	4,828,725	05/09/89	Lai et al.			03/04/88
	4,856,590	08/15/89	Caillier			11/28/86
	4,870,167	09/26/89	Zody, et al.			03/02/87
	4,941,537	07/17/90	Langemeier, et al.			06/22/89
	4,960,876	10/02/90	Molteni, et al.			12/22/88
	5,051,197	09/24/91	Kalfayan, et al.			10/10/90
	5,105,886	04/21/92	Strubhar, et al.			10/24/90
	5,256,651	10/26/93	Phelps, et al.			05/27/92
	5,424,284	06/13/95	Patel et al.			07/02/93
	5,445,223	08/29/95	Nelson, et al.			03/15/94

<b>EXAMINER</b>	<b>DATE CONSIDERED</b>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

<b>Information Disclosure Citation in an Application</b>	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

**U.S. PATENT DOCUMENTS**

		DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
		5,597,783	01/28/97	Audibert, et al			05/04/95
		5,637,556	06/10/97	Argillier, et al			05/04/95
		5,643,460	07/01/97	Marble, et al.			06/30/95
		5,681,796	10/28/97	Nimerick			07/29/94
		5,704,426	01/06/98	Rytlewski, et al.			03/20/96
		5,720,347	02/24/98	Audibert, et al			01/11/96
		5,908,814	06/01/99	Patel, et al.			07/03/95
		5,990,052	11/23/99	Harris			07/25/96
		6,209,646	04/03/01	Reddy, et al			04/21/99
		6,242,390	06/05/01	Mitchell, et al.			07/31/98
		6,281,172	08/28/01	Warren, et al.			04/07/99
		6,291,404	09/18/01	House			02/13/01
		6,562,762	05/13/03	Cowan, et al.			07/03/01
		6,601,648	08/05/03	Ebinger			10/22/01
		6,607,035	08/19/03	Reddy, et al.			10/26/00
		6,626,241	09/30/03	Nguyen			12/06/01
		6,637,517	10/28/03	Qu, et al			01/17/02
		6,656,885	12/02/03	House, et al			01/03/02
		6,743,288	06/01/04	Eoff, et al.			10/28/02
		6,764,981	07/20/04	Eoff, et al			03/21/03
		6,767,867	07/27/04	Chatterji, et al.			04/15/02
		6,767,869	07/27/04	DiLullo, et al			04/09/02
		6,780,822	08/24/04	Cowan, et al			01/21/03
		6,846,420	01/25/05	Reddy, et al			12/19/02
		6,884,760	04/26/05	Brand, et al			05/20/02
		6,962,203	11/08/05	Funchess			03/24/03
		6,978,836	12/27/05	Nguyen, et al			05/23/03
		6,981,552	01/03/06	Reddy, et al			03/21/03
		7,007,752	03/07/06	Reddy, et al			12/04/03
		7,008,908	03/07/06	Chan, et al			11/22/02
		7,036,587	05/02/06	Munoz, Jr., et al			06/27/03
		7,036,589	05/02/06	Nguyen			08/14/03
		7,091,159	08/15/06	Eoff, et al.			09/06/02
		7,182,136	02/27/07	Dalrymple, et al			07/02/03
		7,220,708	05/22/07	Zamora, et al			02/27/03

<b>EXAMINER</b>	<b>DATE CONSIDERED</b>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

<b>Information Disclosure Citation in an Application</b>	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

### U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
--	--------------	-----------------	------	-------	----------	-------------

### NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	
	Office action dated 12/28/2007 from application serial number 10/806,894	12/28/2007
	Office action dated 7/12/2007 from application serial number 10/806,894	7/12/2007
	Office action dated 4/9/2007 from application serial number 10/806,894	4/9/2007
	Office action dated 1/3/2007 from application serial number 10/806,894	1/3/2007
	Office action dated 7/3/2006 from application serial number 10/806,894	7/3/2006
	Notice of allowance dated 1/28/2008 from application serial number 11/102,062	1/28/2008
	Office action dated 6/27/2007 from application serial number 11/102,062	6/27/2007
	Office action dated 5/1/2007 from application serial number 11/122,836	5/1/2007
	Office action dated 11/14/2007 from application serial number 11/122,836	11/14/2007
	Office action dated 2/1/2008 from application serial number 10/440,337	2/1/2008
	Office action dated 11/15/2006 from application serial number 10/440,337	11/15/2006
	Office action dated 5/3/2006 from application serial number 10/440,337	5/3/2006
	Notice of allowance dated 3/23/2006 from application serial number 10/236,722	3/23/2006
	Office action dated 9/28/2005 from application serial number 10/236,722	9/28/2005
	Office action dated 7/5/2005 from application serial number 10/236,722	7/5/2005
	Office action dated 4/19/2005 from application serial number 10/236,722	4/19/2005
	Office action dated 10/20/2004 from application serial number 10/236,722	10/20/2004
	Notice of allowance dated 3/23/2006 from application serial number 10/612,271	3/23/2006
	Notice of allowance dated 7/18/2006 from application serial number 10/825,001	7/18/2006
	Office action dated 1/6/2006 from application serial number 10/825,001	1/6/2006
	Notice of allowance dated 8/17/2006 from application serial number 10/881,198	8/17/2006
	Notice of allowance dated 5/25/2006 from application serial number 10/881,198	5/25/2006
	Notice of allowance dated 3/5/2007 from application serial number 10/893,210	3/5/2007
	Notice of allowance dated 2/27/2007 from application serial number 10/893,210	2/27/2007
	Office action dated 9/12/2006 from application serial number 10/893,210	9/12/2006
	Office action dated 1/14/2008 from application serial number 11/471,148	1/14/2008

<b>EXAMINER</b>	<b>DATE CONSIDERED</b>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

<b>Information Disclosure Citation in an Application</b>	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

### NON-PATENT DOCUMENTS

		<b>DOCUMENT (Including Author, Title, Source, and Pertinent Pages)</b>	
		Office action dated 11/2/2007 from application serial number 11/471,148	11/2/2007
		Office action dated 9/20/2007 from application serial number 11/471,148	9/20/2007
		Office action dated 4/5/2007 from application serial number 11/471,148	4/5/2007
		Office action dated 1/14/2008 from application serial number 11/471,738	1/14/2008
		Office action dated 11/2/2007 from application serial number 11/471,738	11/2/2007
		Office action dated 9/20/2007 from application serial number 11/471,738	9/20/2007
		Office action dated 4/6/2007 from application serial number 11/471,738	4/6/2007
		Office action dated 9/24/2007 from application serial number 10/862,132	9/24/2007
		Office action dated 7/12/2007 from application serial number 10/862,132	7/12/2007
		Office action dated 1/22/2007 from application serial number 10/862,132	1/22/2007
		Office action dated 7/28/2006 from application serial number 10/862,132	7/28/2006
		Proett, et al., <i>Advanced Dual Probe Formation Tester with Transient, Harmonic, and Pulsed Time-Delay Testing Methods Determines Permeability, Skin, and Anisotropy</i> , SPE 64650, 2000, Society of Petroleum Engineers Inc., presented at the SPE International Oil and Gas Conference and Exhibition in China held in Beijing, China, November 7-10, 2000	11/7/00
		Proett, et al., <i>Advanced Permeability and Anisotropy Measurements While Testing and Sampling in Real-time Using a Dual Probe Formation Tester</i> , SPE 62919, 2000, Society of Petroleum Engineers Inc., presented at the 2000 SPE Annual Technical Conference and Exhibition held in Dallas, Texas, October 1-4, 2000	10/1/00
		Bai, et al., <i>Improved Determination of Stress-Dependent Permeability for Anisotropic Formations</i> , SPE/ISRM 78188, 2000, Society of Petroleum Engineers Inc., presented at the SPE/ISRM Rock Mechanics Conference held in Irving, Texas, October 20-23, 2002	10/20/02
		Parker, et al., <i>Laser Drilling: Effects of Beam Application Methods on Improving Rock Removal</i> , SPE 84353, 2003, Society of Petroleum Engineers Inc., presented at the SPE Annual Technical Conference and Exhibition held in Denver, Colorado, October 5-8, 2003	10/5/03
		Xu, et al., <i>Modeling of Laser Spallation Drilling of Rocks for Gas--and Oilwell Drilling</i> , SPE 95746, 2005, Society of Petroleum Engineers Inc., presented at the 2005 SPE Annual Technical Conference and Exhibition held in Dallas, Texas, October 9-12, 2005	10/9/03
		Batareseh, et al., <i>Well Perforation Using High-Power Lasers</i> , SPE 84418, 2003, Society of Petroleum Engineers Inc., presented at the SPE Annual Technical Conference and Exhibition held in Denver, Colorado, October 5-8, 2003	10/5/03

<b>EXAMINER</b>	<b>DATE CONSIDERED</b>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	